

## Pulse Height Analysis of 3D pCVD Diamond Detectors

RD42 Meeting

**Michael Reichmann**

9th May 2019

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- 3 Setup at PSI
- 4 Pulse Height Calibration
- 5 Analysis
- 6 Results
- 7 Conclusion

## Section 1

### Introduction

# Diamond as Detector Material

- innermost tracking layers  $\rightarrow$  highest radiation damage  $\mathcal{O}$  (GHz/cm<sup>2</sup>)
- $\rightarrow$  **R&D towards more radiation tolerant detector designs and/or materials**

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- advantageous properties
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## Work at ETH:

- investigate signals and radiation tolerance in various detector designs:
  - ▶ Pad Detectors  $\rightarrow$  whole diamond as single cell readout
  - ▶ Pixel Detectors  $\rightarrow$  diamond sensor on pixel readout chip
  - ▶ 3D Pixel Detectors  $\rightarrow$  3D diamond detector on pixel readout chip

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- investigate signals and radiation tolerance in various detector designs:
  - ▶ Pad Detectors
  - ▶ Pixel Detectors
  - ▶ **3D Pixel Detectors**  $\rightarrow$  this talk

## Detectors

	<b>II6-A2</b>	<b>II6-B6</b>
manufacturer	II-VI Inc.	II-VI Inc.
diamond type	poly-crystal	poly-crystal
size	$\sim 4 \text{ mm} \times 4 \text{ mm}$	$\sim 4 \text{ mm} \times 4 \text{ mm}$
thickness	$\sim 500 \mu\text{m}$	$455 \mu\text{m}$
irradiation	none	none
construction	summer 2016	summer 2017
3D drilling	Oxford	Oxford
<b>3D cell size</b>	<b><math>150 \mu\text{m} \times 100 \mu\text{m}</math></b>	<b><math>50 \mu\text{m} \times 50 \mu\text{m}</math></b>
<b>columns</b>	<b><math>20 \times 30</math> (600)</b>	<b><math>60 \times 62</math> (3720)</b>
pixel chip	PSI46digV2.1respin (CMS)	PSI46digV2.1respin (CMS)
pixel pitch	$150 \mu\text{m} \times 100 \mu\text{m}$	$150 \mu\text{m} \times 100 \mu\text{m}$
ganged cells	$1 \times 1$	$2 \times 3$ (6 cells)
bump & wire bonding	Princeton	Princeton

Table: 3D Pixel Detector Properties.



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Table: 3D Pixel Detector Properties.

- II6-A2 broke in October 2016 (chip malfunctioned) → successful re-bonding
- II6-B6 has long history of breaking ...

# Measurements

	Oct 16	May 17	Aug 17	Sep 18	Oct 18	Oct 18
place	PSI	PSI	PSI	CERN	CERN	PSI
<b>I16-A2</b>	✓	✓	✓	✓	✓	✓
<b>I16-B6</b>	✗	✗	✓	✓	✓	✓

Table: 3D Pixel Detector Measurements.

- standard rate and voltage scans
- rise time scans: change of amplifier rise time at fixed flux and voltage
- angle scans: change of incident angle at fixed flux and voltage

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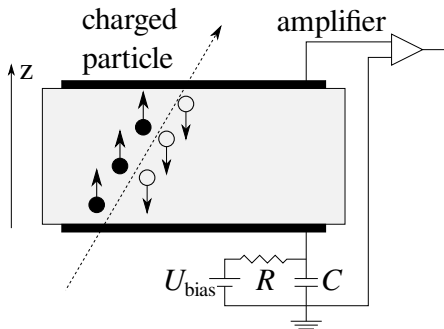
## History of II6-B2:

- 06/2017 - sensor processing and detector fabrication
- 08/2017 - first measurement → high efficiency → pedestal in pulse height
- 04/2018 - several pixels malfunction → re-bump-bonding to new chip
- 06/2018 - sensor detaches while shipping → re-bump-bonding, fixate with silguard
- 10/2018 - at PSI: efficiency worsens and sensor detaches again

## Section 2

### 3D Pixel Detector

# Diamond as Particle Detector



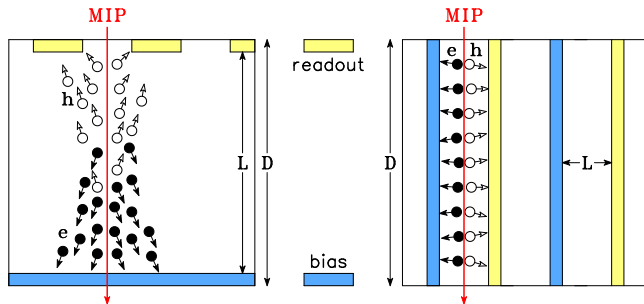
(a) Detector Schematics



(b) 15 cm  $\varnothing$  pCVD Diamond Wafer

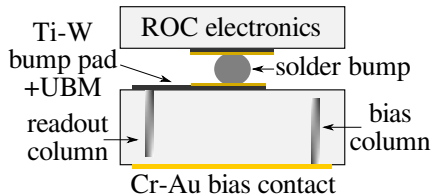
- detectors operated as ionisation chambers
- metallisation on both sides
- poly-crystals produced in large wafers

# Working Principle

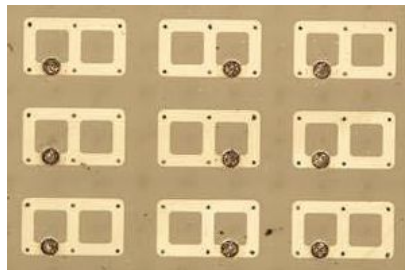


- after large radiation fluence all detectors become trap limited
- bias and readout electrode inside detector material
- same thickness  $D \rightarrow$  same amount of induced charge  $\rightarrow$  shorter drift distance  $L$
- **increase collected charge in detectors with limited mean drift path (Schubweg)**

# Bump Bonding



(a) Bump bond schematics



(b)  $3 \times 2$  bump pads

- electrodes (columns) drilled with femto-second laser
- connection to bias and readout with surface metallisation
- ganging of cells to match pixel pitch of readout-chip (ROC)
- small gap ( $\sim 15 \mu\text{m}$ ) to the surface to avoid a high voltage break-through

## Section 3

### Setup at PSI



# Pixel Telescope

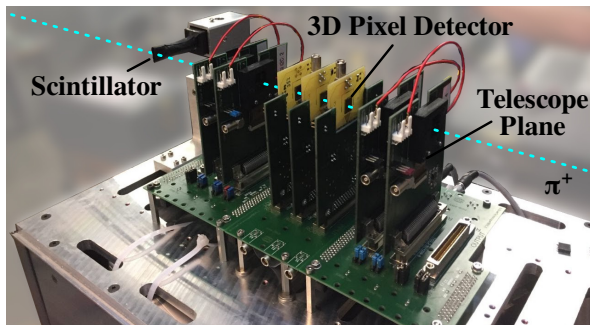
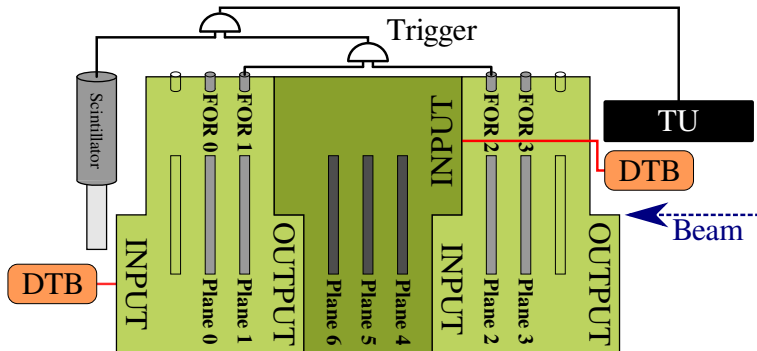


Figure: modular ETH beam telescope in pixel configuration

- 4 tracking planes  $\rightarrow$  trigger (fast-OR)  $\rightarrow$  adjustable area (max  $8\text{ mm} \times 7.8\text{ mm}$ )
- up to 3 DUT planes (any digital pixel detector)
- scintillator for precise trigger timing  $\rightarrow \mathcal{O}(1\text{ ns})$

# Schematic Setup

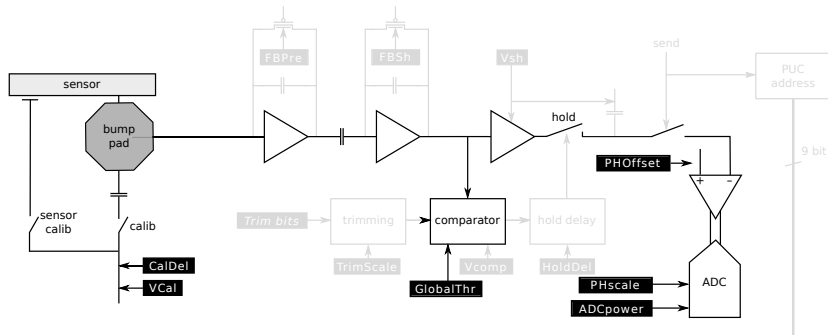


- independent telescope module for DUTs (dark green)
- scintillator → precise trigger timing of  $\mathcal{O}(1 \text{ ns})$
- Trigger Unit (TU) → strongly simplifying setup
- global trigger → (Plane 1 AND Plane 2) AND Scintillator

## Section 4

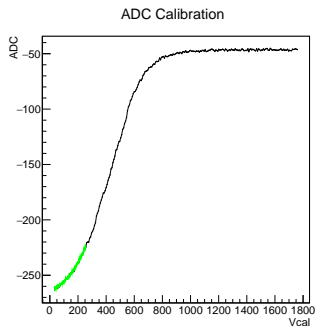
### Pulse Height Calibration

# Pixel Unit Cell

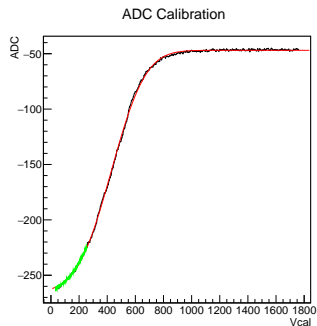


- inject calibration signal ( $\sim vcal$ ) through sensor into same circuit as real signals
- shaping, amplification, threshold check
- set amplification offset
- convert to 8 bit adc value with adjustable scale  $\rightarrow$  readout

# ADC Calibration



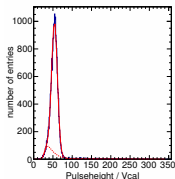
(a) ADC calibration for single pixel.



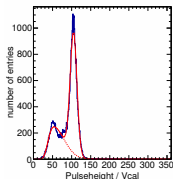
(b) Error function fit.

- measure adc values for calibration pulses with different vcal
- adc follows error function and saturates for high vcal
- fit every pixel and save fit parameters
- adjust adc offset and range with DACs of the chip

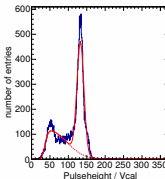
# Vcal Calibration (Silicon)



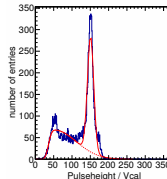
(a) Zn target.



(b) Mo target.



(a) Ag target.



(b) Sn target.

- measure energy spectra of  $K_{\alpha}$  lines of four metal targets using ADC-calibration

# Vcal Calibration (Silicon)

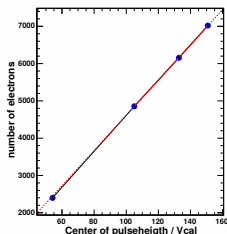
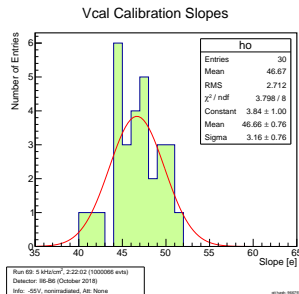


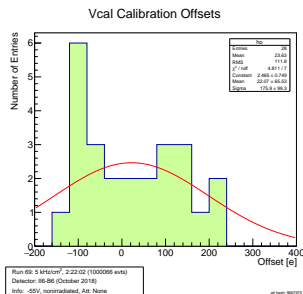
Figure: Vcal Calibration.

- measure energy spectra of  $K_{\alpha}$  lines of four metal targets using ADC-calibration
- linear dependence of energy [e] and vcal
- fit  $K_{\alpha}$  points with straight line (similar for each chip)
- impossible to do calibration with diamond (energy too low)

# Vcal Calibration (Silicon)



(a) Vcal slopes.



(b) Vcal offsets.

- measure energy spectra of  $K_\alpha$  lines of four metal targets using ADC-calibration
- linear dependence of energy [e] and vcal
- fit  $K_\alpha$  points with straight line (similar for each chip)
- impossible to do calibration with diamond (energy too low)
  - use general values from silicon:  $e = 46.5 \cdot \text{vcal}$



## Section 5

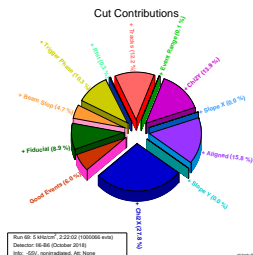
### Analysis

## Cuts

Cut	Excluded Events
event range	first minute of the run due to various beam conditions
beam interruptions	during rate changes of the beam due to beam interruption
aligned	DUT and Telescope are not aligned (event-wise)
trigger phase	Chip trigger timing is incorrect
tracks	not all telescope planes have exactly one cluster
chi2 (x/y)	badly fit tracks ( $>50\%$ quantile)
track slope (x/y)	large angles of the tracks ( $>2\text{ deg}$ )
rhit	large DUT residual ( $>100\text{ mm}$ )
pixel mask	noisy pixels
fiducial	not in selected (fiducial) area of the DUT

Table: Analysis cut flow.

- cuts applied in order of the table
- largest contribution usually by chi2, tracks and fiducial cuts

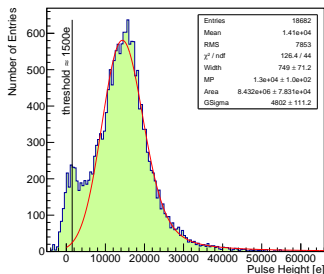


## Section 6

### Results

May 2017

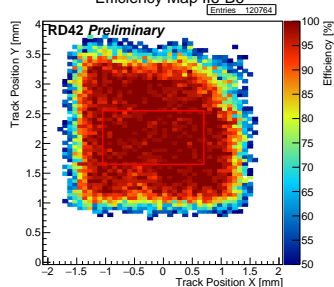
Pulse Height Distribution - I16-B6



Run 139: 67 kHz/cm<sup>2</sup>, 0.24:52 (1000650 evts)  
 Detector: I16-B6 (August 2017)  
 Info: -55V, nonirradiated, Att:

git hash: 16c97779

Efficiency Map I16-B6



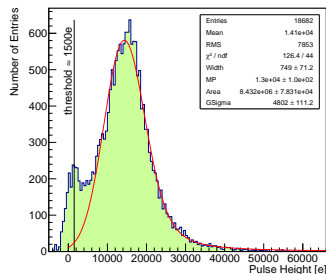
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- pulse height looks OK, but pedestal of unknown origin (cannot be real)
- Langau MPV: 13 500 e
- uniform efficiency

May 2017

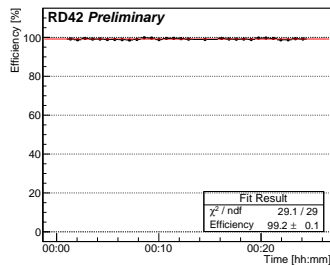
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 Detector: I16-B6 (August 2017)  
 Info: -55V, nonirradiated, Att:

git hash: 16c9779

Hit Efficiency I16-B6



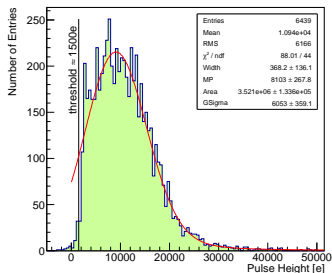
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- pulse height looks OK, but pedestal of unknown origin (cannot be real)
- Langau MPV: 13 500 e
- uniform efficiency
- high efficiency of  $(99.2 \pm 0.1) \%$

Oct 2018

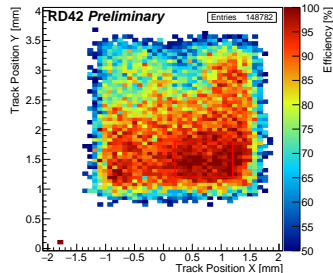
Pulse Height Distribution - II6-B6



Run 69: 5 kHz/cm<sup>2</sup>, 2.22-02 (1000066 evts)  
 Detector: II6-B6 (October 2018)  
 Info: -55V, nonirradiated, Att: None

git hash: 9a9c979

Efficiency Map II6-B6



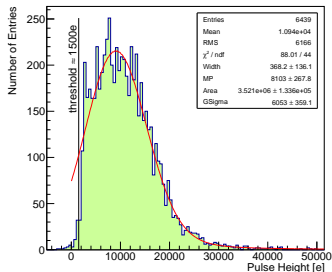
Run 69: 5 kHz/cm<sup>2</sup>, 2.22-02 (1000066 evts)  
 Detector: II6-B6 (October 2018)  
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git hash: 9a9c979

- left part of pulse height distribution not understood
- Langau MPV: 8000 e
- efficiency much less uniform  $\rightarrow$  already loose bumps?

Oct 2018

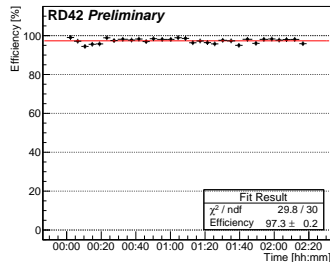
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gr-had: 10/07/19

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- left part of pulse height distribution not understood
- Langau MPV: 8000 e
- efficiency much less uniform → already loose bumps?
- lower efficiency of  $(97.3 \pm 0.2) \%$

## Section 7

### Conclusion



# Conclusion

- empty
- moreempty
- moremoreempty

# DEL FIN

